

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/566,116 Confirmation No. 3700  
Applicant : Akihisa Inoue et al.  
371 Filed : January 24, 2006  
Art Unit : 1742  
Examiner : Weiping Zhu  
Customer No. : 00270  
Title : SPUTTERING TARGET AND METHOD FOR PRODUCTION THEREOF

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment submitted with a Request for Continued Examination (RCE). It is in response to the FINAL Office Action dated April 30, 2007. Kindly amend the application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.